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2314



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Cohen et al. Examiner: Louie, W. #8 V-30-02  
Serial No.: 09/502,729 Group: Art Unit 2814  
Filed: February 11, 2000 Docket: YO999-573 (728-163)  
For: DIFFUSION BARRIER LAYER  
AND SEMICONDUCTOR DEVICE  
CONTAINING SAME Dated: January 29, 2002  
FEB 25 2002  
ELECTRONIC CENTER 2000  
RECEIVED

Commissioner for Patents  
Washington, D.C. 20231

CERTIFICATION UNDER 37 C.F.R. §1.97(e)(1)  
AND INFORMATION DISCLOSURE STATEMENT

Sir:

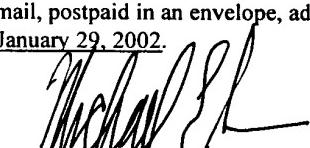
Pursuant to Applicants' duty of disclosure, the information listed in the attached Form PTO-1449 is brought to the attention of the Examiner. The listed items were cited in a foreign Search Report issued in corresponding International Application No. GB 0102506.3. Copies of the cited art along with the Search Report are enclosed.

The citation of the listed items is not a representation that they constitute a complete or exhaustive listing of the relevant art or that the disclosures are prior art. The items listed are submitted in good faith, but are not intended to substitute for the Examiner's search. It

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

I hereby certify that this correspondence (and any document referred to as being attached or enclosed) is being deposited with the United States Postal Service as first class mail, postpaid in an envelope, addressed to the: Assistant Commissioner for Patents, Washington, D.C. 20231 on January 29, 2002.

Dated: January 29, 2002

  
Michael E. Carmen

is hoped, however, that in addition to apprising the Examiner of these particular items, they will assist in identifying fields of search and in making as full and complete a search as possible.

The filing of this Information Disclosure Statement is not an admission that the information cited herein is, or is considered to be, material to patentability as defined in 37 C.F.R. §1.56(b).

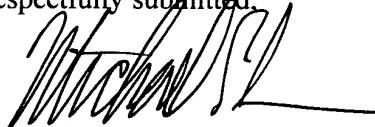
CERTIFICATION UNDER 37 C.F.R. §1.97(e)(1)

The undersigned hereby certifies that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the statement.

Please charge any deficiency as well as any other fee(s) which may become due under 37 C.F.R. §1.16 and/or 1.17 at any time during the pendency of this application, or credit any overpayment of such fee(s) to Deposit Account No. 04-1121. Also, in the event any extensions of time for responding are required for the pending application(s), please treat this paper as a petition to extend the time as required and charge Deposit Account No. 04-1121 therefor. **TWO (2) COPIES OF THIS SHEET ARE ENCLOSED.**

The claims of the application as now presented are believed to patentably distinguish over the prior art and to be in condition for allowance. Early and favorable consideration of this application are respectfully requested.

Respectfully submitted,



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Form PTO-1449

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO. 728-163

SERIAL N.O.

09/502,729

INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT

(Use several sheets if necessary)

APPLICANT  
Cohen, et al.

FILING DATE February 11, 2000

GROUP

Art Unit 2814

## U.S. PATENT DOCUMENT

EXAMINER INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	5 8 6 1 6 5 1	01/19/99	Brasen, et al.			
	5 5 2 1 1 2 7	05/28/96	Hori			

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
						YES
	2 3 3 4 8 1 8	01/09/99	United Kingdom			NO

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	Conference Record of the 1988 IEEE International Symposium on Electrical Insulation, Cambridge USA, 5-8 June 1988, Gerstenberg, On structure and properties of plasma polymerized organo-silicon films , pages 141-144.

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.